

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Group Art Unit: Unknown

Michial Duff Howell et al.

Examiner: Unknown

Application No.: NEW

PRELIMINARY AMENDMENT

Filed: HEREWITH

For: METHOD AND APPARATUS FOR
PREPARING SEMICONDUCTOR
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M/S PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examining the above-identified application, please enter the following amendments:

Amendments to the Specification begin on page 2 of this paper.**Amendment to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.**Arguments** begin on page 5 of this paper.